

<b>Notice of References Cited</b>	Application/Control No. 10/652,635		Applicant(s)/Patent Under Reexamination SUN ET AL.	
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X	B	US-2003/0216044 A1	11-2003	Lin et al.	438/689
X	C	US-5,244,843	09-1993	Chau et al.	438/452
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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